

Special Issue

Automation and Control Systems Technology in Industry

Message from the Guest Editors

In this Special Issue, original research articles and reviews are welcome. Research areas may include (but are not limited to) the following:

Advanced AI methods for automation and control in industrial processes.

Cyber-physical systems, digital twins, and smart manufacturing.

Reinforcement learning and adaptive control for energy and process industries.

Industrial applications of physics-informed and explainable AI.

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Deadline for manuscript submissions

closed (20 April 2026)



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Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal *Applied Sciences* has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

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